

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE
INFORMATION DISCLOSURE STATEMENT AND PETITION FOR
CONSIDERATION THEREOF UNDER 37 C.F.R. § 1.97(d)

APPLICANTS: Bennarsten et al. GROUP ART UNIT: 3761
SERIAL NO.: 09/733,064 EXAMINER: M. Mendoza
FILED: December 11, 2000 CONFIRMATION NO.: 2760
TITLE: "A HIGH FREQUENCY OSCILLATOR VENTILATOR"

MAIL STOP AF
Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

S I R:

In accordance with the provisions of 37 C.F.R. § 1.56, Applicants request that citation and examination of the following documents be made during the course of examination of the above-referenced application for United States Letters Patent.

AA United States Patent No. 5,862,802
AB United States Patent No. 5,555,880
AC United States Patent No. 4,788,974
AD United States Patent No. 4,747,402
AE United States Patent No. 4,637,386
AL United Kingdom Application 2 177 311
AM European Application 1 106 197

EXPLANATION OF RELEVANCE


The above references were among the references cited in a Search Report dated September 12, 2003 rendered by the European Patent Office during examination proceedings of the counterpart European application. A copy of the European Search Report is enclosed. The other references cited therein already have been made of record in the present United States application.

Copies of each of the above references together with Form 1449 are submitted herewith. Since all of these references are in English, no further commentary beyond the designation in the European Search Report is necessary.

This Information Disclosure Statement is being submitted pursuant to 37 C.F.R. §1.97(d), after the final rejection. Accordingly, the undersigned counsel states, pursuant to 37 C.F.R. §1.97(e)(1) that each of the above items was first cited by a foreign Patent Office during examination of a counterpart foreign application not more than three months prior to the filing of this Information Disclosure Statement. Also, this Information Disclosure Statement is accompanied by the fee required by 37 C.F.R. § 1.17(p), and therefore consideration of the prior art identified herein is respectfully requested.

All claims of the application are submitted to be patentable over the teachings of the above references, taken singly or in combination, or in combination with any of the other references already of record.

Submitted by,



(Reg. 28,982)

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Attorneys for Applicants.

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, Virginia 22313-1450 on November 25, 2003.



STEVEN H. NOLL

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Form PTO-1449 Sheet 1 of 1

**INFORMATION DISCLOSURE CITATION
IN AN APPLICATION**
(use several sheets if necessary)

Docket No. P00,1832		Serial No. 09/773,064	
Applicant Bennarsten et al.			
Filing Date December 11, 2000		Group Art Unit 3761	

U.S. PATENT DOCUMENTS

Examiner's Initials		Document Number	Date	Name	Class	Subclass	Filing Date (if appropriate)
	AA	5,862,802	01/26/99	Bird			
	AB	5,555,880	09/17/96	Winter et al.			
	AC	4,788,974	12/06/88	Phuc			
	AD	4,747,402	05/31/88	Reese et al.			
	AE	4,637,386	01/20/87	Baum			
	AF						
	AG						
	AH						
	AI						
	AJ						
	AK						

FOREIGN PATENT DOCUMENTS

		Document Number	Date	Country	Class	Subclass	Translation	
							Yes	No
	AL	2 177 311	01/27/87	United Kingdom				
	AM	1 106 197	06/13/2001	Europe				
	AN							
	AO							
	AP							
	AQ							
	AR							
	AS							

OTHER PRIOR ART (Including Author, Title, Date, Pertinent Pages, Etc.)

	AT	
	AU	
	AV	
	AW	

Examiner	Date Considered
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***EXAMINER:** Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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